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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Wilhelm STEIN et al.

Serial No.: 10/789,199

Filed: February 26, 2004

For: Electrical Contact for Optoelectronic
Semiconductor Chip and Method for its
Production

Examiner: LOUIE, Wai Sing
Group Art: 2814

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Name of applicant, assignee or Registered Representative

Thomas Langer

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AMENDMENT AFTER FINAL REJECTION

SIR:

In response to the Final Office Action dated April 6, 2006, please amend the above-
identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 7 of this paper.